

PALM INTRANET

Day: Thursday Date: 6/24/2004

Time: 18:54:12

Inventor Name Search Result

Your Search was:

Last Name = MATSUOKA First Name = RYOICHI

			<u></u>		
Application#	Patent#	Status	Date Filed	Title	Inventor Name 10
10823104	Not Issued	020	04/13/2004	METHOD AND APPARATUS OF EVALUATING LAYER MATCHING DEVIATION BASED ON CAD INFORMATION	MATSUOKA, RYOICHI
10607295	Not Issued	020	06/26/2003	WAFERLESS METROLOGY RECIPE GENERATOR AND GENERATING METHOD	MATSUOKA, RYOICHI
10147417	6757875	150	05/16/2002	METHOD AND APPARATUS OF EVALUATING LAYER MATCHING DEVIATION BASED ON CAD INFORMATION	MATSUOKA, RYOICHI
09934005	Not Issued	161	08/20/2001		MATSUOKA, RYOICHI
09933785	Not Issued	161	08/20/2001	MASK DEFECT CHECKING METHOD AND DEVICE FOR ELECTRON BEAM EXPOSURE	MATSUOKA, RYOICHI
<u>99903790</u>	Not Issued	030	07/12/2001		MATSUOKA, RYOICHI
09903601	Not Issued	030	07/12/2001	SEMICONDUCTOR WAFER PATTERN SHAPE EVALUATION METHOD AND DEVICE	MATSUOKA, RYOICHI
09903600	Not Issued	030	07/12/2001	WAFER PATTERN OBSERVATION METHOD AND DEVICE	MATSUOKA, RYOICHI
09537945	6724929	150	03/29/2000	WAFER INSPECTING APPARATUS	MATSUOKA, RYOICHI

| O9537944 | Not | 161 | O3/29/2000 | WAFER INSPECTING | MATSUOKA, | RYOICHI

Inventor Search Completed: No Records to Display.

Search Another: Inventor

Last Name
First Name
RYOICHI
Search

To go back use Back button on your browser toolbar.

Back to PALM | ASSIGNMENT | OASIS | Home page